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	Drew Richards  son the cover sheet with the country of REMAINS) CLOSED in this apported appropriate communication is subject to ad MPEP 1308.  r 35 U.S.C. § 119(a)-(d) or (f).  then received.  then received in Application No

## **EXAMINER'S AMENDMENT**

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Mark Marcelli on 5/13/05.

The application has been amended as follows:

In the claims:

Claim 13 lines 1-2, delete "A method of creating an electron charge effect monitoring device" and replace therewith --A method for monitoring electron charge effect occurring during semiconductor processing--

2. The following is an examiner's statement of reasons for allowance:

Prior art of record fails to teach, disclose, or suggest, the method of monitoring electron charge effect occurring during semiconductor processing as claimed including measuring a voltage required to induce FN tunneling based current in the structure formed as claimed. It is noted that in the previous Office Actions the step of measuring was not given patentable weight as it was considered an intended use limitation that did not manipulatively affect the process of formation. The previous Office Actions incorrectly interpreted claims 1-6, 12, 33, 35 and 36 as being drawn towards a method of making. Upon review of the preamble of these claims, it is noted that they are drawn

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towards a method of monitoring and thus the measuring limitations have been given full patentable weight.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to N. Drew Richards whose telephone number is (571) 272-1736. The examiner can normally be reached on Monday-Friday 9:00-5:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Tom Thomas can be reached on (571) 272-1664. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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